Search Notes

Application/Control No.	Applicant(s)/Patent under Reexamination	
10/752,642	NAKAMURA ET AL.	
Examiner	Art Unit	
Chris C. Chu	2815	

Chris C. Chu

F	SEARCHED				
Class	Subclass	Date	Examiner		
257	E21.174, E21.582 & E21.584	11/27/2007	C.C.		
257	758 & 751	11/27/2007	C.C.		
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	1				

INTERFERENCE SEARCHED					
Class	Subclass	Date	Examiner		
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SEARCH NOTES (INCLUDING SEARCH STRATEGY)				
	DATE	EXMR		
Searched in US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; and IBM_TDB;	11/27/2007	C.C.		
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